

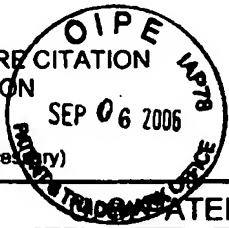
CUSTOMER NO.: 27623

Sheet 1 of 1

FORM PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)



Docket Number (Optional)

YOR920010518US1

Application Number

10/817,179

Applicant

Clevenger

Filing Date

April 2, 2004

Group Art Unit

2818

PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

/TL/	E. Delamarche et al., "Lithography Beyond Light: Microcontact Printing with Monolayer Resists," IBM J. Res. Develop. 41, pp. 159-170 (1997).
	E. Delamarche et al., "Stability of Molded Polydimethylsiloxane Microstructures," Adv. Mater. 9, pp. 741-746 (1997).
/TL/	E. Delamarche et al., "Transport Mechanisms of Alkanethiols during Microcontact Printing on Gold," Journal of Phys. Chem., Vol. 102, pp. 3324-3334. (1998).
	L. Libioulle et al., "Contact-Inking Stamps for Microcontact Printing of Alkanethiols on Gold," Langmuir Vol. 15, pp. 300-304 (1999).
/TL/	H. Schmid et al., "Light-Coupling Masks for Lensless, Sub-Wavelength Optical Lithography," Appl. Phys. Lett. Vol 72, pp. 2379-2381 (1998).

EXAMINER

/Thao Le/

DATE CONSIDERED

09/16/2007

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.